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IFW

In re Patent Application of: Allan Rosencwaig et al.

Atty Docket No. TWI-8520

Application No.: 10/717,316

Filed: November 19, 2003

Confirmation No.: 8272

For: OPTICAL INSPECTION EQUIPMENT FOR SEMICONDUCTOR WAFERS WITH PRECLEANING

M/S AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	7	MINUS	20	0	x \$50 =	\$0
INDEP.	1	MINUS	3	0	x \$200 =	\$0
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS					+ \$360	\$0
TOTAL						\$0

Small Entity 50% Filing Fee Reduction (if applicable)

\$0

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- ☒ No additional fee is required.
- ☐ A check in the amount of \$_____ is attached.
- ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. TWI-8520.
A duplicate copy of this sheet is enclosed.
- ☒ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

Dated: January 5, 2005

By: 

Michael A. Stallman (Reg. No. 29,444)
Attorneys for Applicant(s)

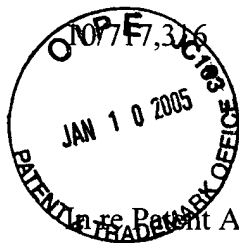
CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 6, 2005.

Dated: January 6, 2005

By: 

Georgia K. Stith



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Allan Rosencwaig et al.

Application No.: 10/717,316

Filed: November 19, 2003

For: OPTICAL INSPECTION EQUIPMENT
FOR SEMICONDUCTOR WAFERS
WITH PRECLEANING

Confirmation No.: 8272

Group Art Unit: 2877

Examiner: Roy M. Punnoose

**RESPONSE TO OFFICE ACTION
MAILED NOVEMBER 2, 2004**353 Sacramento Street, Suite 2200
San Francisco, CA 94111
Telephone: (415) 772-4900
Facsimile: (415) 398-2890M/S AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited
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Box 1450, Alexandria, VA 22313-1450 on January 6, 2005.
STALLMAN & POLLOCK LLP

Dated: 01/6/2005

By:

Georgia K. Stith

Sir:

In response to the Office Action dated November 2, 2004, please amend the above-
identified application as follows:**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this
paper.**Remarks** begin on page 4 of this paper.